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First Named Inventor	Zhongze Wang	<b>TRANSMITTAL FORM UNDER 37 CFR 1.10 (LARGE ENTITY)</b>
Serial No.	10/758,059	
Filing Date	January 15, 2004	
Group Art Unit	2823	
Examiner Name	Thanh V. Pham	
Confirmation Number	5110	
Attorney Docket No.	400.147US02	
Title: FET HAVING EPITAXIAL SILICON GROWTH		

Mail Stop: AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

<b>Enclosures</b>					
The following documents are enclosed:					
<u>X</u>	Response to Final Office Action Under 37 C.F.R. 1.116 (29 pgs.);				
<u>X</u>	a return postcard.				
Please charge any additional fees or credit any overpayments to Deposit Account No. 501373.					
<b><u>CUSTOMER NUMBER 27073</u></b>					
Leffert Jay & Polglaze, P.A. P. O. Box 581009 Minneapolis, MN 55458-1009					
<b>Submitted By</b>					
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Signature	<i>Tod A. Myrum</i>			Date	June 5, 2006
<b>Certificate of Mailing</b>					
<b>"Express Mail" mailing label number: EV836365129US Date of Deposit: June 5, 2006</b>					
These papers and fees are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR §1.10 on the date indicated above and addressed to Mail Stop: AF, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.					
(LARGE ENTITY TRANSMITTAL UNDER 37 C.F.R. 1.10)					

First Named Inventor	Zhongze Wang	<b>REPLY UNDER 37 C.F.R. §1.116 – EXPEDITED PROCEDURE – TECHNOLOGY CENTER 2800</b>  
Serial No.	10/758,059	
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In response to the Final Office Action mailed April 4, 2006, please consider the following: